
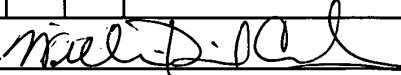


Form PTO-1385		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1385		SERIAL NO. 09/652,533	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Gurtej S. Sandhu			
				FILING DATE August 31, 2000		GROUP 2823	
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AM						
	AN						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AO	J. Aarik, et al, Control of Thin Film Structure by Reactant Pressure in Atomic Layer Deposition of TiO ₂ , Journal of Crystal Growth Vol. 169, (1996), pgs. 496-502.					
	AP						
	AQ						
	AR						
EXAMINER 		DATE CONSIDERED 12/23/02					
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							